

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Group Art Unit: 2813
Junichi SATO	)	Examiner: Laura M. Schillinger
	)	
Application No.: 10/828,882	)	
	)	
Filed: April 21, 2004	)	
	)	
For: SEMICONDUCTOR THIN FILM	)	
AND METHOD OF FABRICATING	)	
SEMICONDUCTOR THIN FILM,	)	Confirmation No.: 5622
APPARATUS FOR FABRICATING	)	
SINGLE CRYSTAL SEMICONDUCTOR	)	
THIN FILM, AND METHOD OF	)	
FABRICATING SINGLE CRYSTAL THIN	)	
FILM, SINGLE CRYSTAL THIN FILM	)	
SUBSTRATE, AND SEMICONDUCTOR	)	
DEVICE	)	

June 29, 2007

**FILED ELECTRONICALLY VIA EFS-WEB**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT ACCOMPANYING**  
**REQUEST FOR CONTINUED EXAMINATION**

Dear Sir:

Prior to further prosecution on the merits, please enter the following amendments and consider the following remarks.